L Number	Hits	Search Text	DB	Time stamp
1	47205	((force load stres strain weight) near3 (test$5 detect$5 sens$5 estimat$5 evalut$5 determin$5 measur$5 transducer cell meter gauge monitor$5)).clm.	USPAT; EPO; JPO	2004/11/02 12:27
2	287	(((force load stres strain weight) near3 (test$5 detect$5 sens$5 estimat$5 evalut$5 determin$5 measur$5 transducer cell meter gauge monitor$5)).clm.) and ((upper lower top bottom) near3 (electrode conduct$5)).clm.	USPAT; EPO; JPO	2004/11/02 12:27
3	77	((((force load stres strain weight) near3 (test$5 detect$5 sens$5 estimat$5 evalut$5 determin$5 measur$5 transducer cell meter gauge monitor$5)).clm.) and ((upper lower top bottom) near3 (electrode conduct$5)).clm.) and substrate.clm.	USPAT; EPO; JPO	2004/11/02 12:27
4	19	(((((force load stres strain weight) near3 (test$5 detect$5 sens$5 estimat$5 evalut$5 determin$5 measur$5 transducer cell meter gauge monitor$5)).clm.) and ((upper lower top bottom) near3 (electrode conduct$5)).clm.) and substrate.clm.) and ("n-type" "p-type")	USPAT; EPO; JPO	2004/11/02 12:31
5	21	((((((force load stres strain weight) near3 (test$5 detect$5 sens$5 estimat$5 evalut$5 determin$5 measur$5 transducer cell meter gauge monitor$5)).clm.) and ((upper lower top bottom) near3 (electrode conduct$5)).clm.) and substrate.clm.) and capacit$7.clm.	USPAT; EPO; JPO	2004/11/02 12:32
6	13	(((((((force load stres strain weight) near3 (test$5 detect$5 sens$5 estimat$5 evalut$5 determin$5 measur$5 transducer cell meter gauge monitor$5)).clm.) and ((upper lower top bottom) near3 (electrode conduct$5)).clm.) and substrate.clm.) and ("n-type" "p-type")) and capacit$7	USPAT; EPO; JPO	2004/11/02 12:34
7	13	(((((((force load stres strain weight) near3 (test$5 detect$5 sens$5 estimat$5 evalut$5 determin$5 measur$5 transducer cell meter gauge monitor$5)).clm.) and ((upper lower top bottom) near3 (electrode conduct$5)).clm.) and substrate.clm.) and ("n-type" "p-type")) and capacit$7) and (semiconductor transistor)	USPAT; EPO; JPO	2004/11/02 12:35
8	14	((((((force load stres strain weight) near3 (test$5 detect$5 sens$5 estimat$5 evalut$5 determin$5 measur$5 transducer cell meter gauge monitor$5)).clm.) and ((upper lower top bottom) near3 (electrode conduct$5)).clm.) and substrate.clm.) and capacit$7.clm.) and (semiconductor transistor)	USPAT; EPO; JPO	2004/11/02 12:35

Mary Noori
11/2/04